



Docket No. F-9089

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Joachim MAI, et al.
Serial No. : 10/578,047
Filed : May 1, 2006
For : METHOD AND APPARATUS FOR ION BEAM
PROCESSING OF SURFACES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Preliminary to examination, please amend the above-identified patent application as follows: